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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. TAI, et al.

Serial No.: 10/784,996

Filed: FEBRUARY 25, 2004

Title: PROCESS FOR PREPARING PHOSPHOR PATTERN FOR FIELD EMISSION DISPLAY PANEL, PHOTOSENSITIVE ELEMENT FOR FIELD EMISSION DISPLAY PANEL, PHOSPHOR PATTERN FOR FIELD EMISSION DISPLAY PANEL AND FIELD EMISSION DISPLAY PANEL

Group AU: 1756

Examiner: John A. McPherson

Confirm. No.: 9776

RESPONSE AFTER FINAL REJECTION

Mail Stop: AF- NO FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

June 21, 2006

SIR:

In response to the Office Action mailed March 21, 2006, Applicants respectfully submit the following remarks, and enclosed Declaration Under 37 CFR §1.132, for overcoming the sole basis for rejection of claims in this Office Action mailed March 21, 2006.

That is, the sole basis for rejection of claims in this Office Action mailed March 21, 2006, is the rejection of claims 1 and 2 as anticipated by the teachings of U.S. Patent No. 6,416,931. In response to the previous "unequivocal statement" on page 3 of the Amendment filed December 28, 2005, for establishing that the subject matter in No. 6,416,931 is not "by another" and thus not prior art under 35 USC §102(e), the Examiner contends that the "unequivocal statement" must be presented in the form of a Declaration signed by the inventors. This contention by the Examiner is respectfully traversed. It is respectfully submitted that Manual of